

31000 U.S. PTO  
10/039459  
11/07/01

PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10039459	11/07/2001	117	15	1765	Seng

**\*\*APPLICANTS:** Sreedharamurthy Hariprasad; Banan Mohsen; Haider Jolani;

**\*\*CONTINUING DATA VERIFIED:**

THIS APPLN CLAIMS BENEFIT OF 60/258,296 12/26/2000

**\*\* FOREIGN APPLICATIONS VERIFIED:**

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no

35 USC 119 conditions met ☐ yes ☐ no

Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

MEMC 99-1250/2441.1

**TITLE :** Apparatus and process for the preparation of low-iron single crystal silicon substantially free of agglomerated intrinsic point defects

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

**NOTICE OF ALLOWANCE MAILED**

**CLAIMS ALLOWED**

Assistant Examiner

Total Claims

Print Claim for  
O.G.

**ISSUE FEE**

Amount Due

Date Paid

**DRAWING**

Sheets Drwg.

Figs. Drwg.

Print Fig.

Primary Examiner

**PREPARED FOR ISSUE**

Application Examiner



**TERMINAL**

**DISCLAIMER**

**WARNING:** The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.

FILED WITH:

☐ DISK (CRF)

☐ CD-ROM

(Attached in pocket on right inside flap)